

Notice of References Cited	Application/Control No. 10/654,954	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Meless N. Zewdu	Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2006/0165046 A1	07-2006	Del Prado Pavon, Javier	370/350
*	C	US-2005/0174973 A1	08-2005	Kandala et al.	370/338
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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